

In re Application

Jeffrey W. Carr

Inventor: Appln. No.:

10/002,035

Confirm. No.: 5043 Filed:

November 1, 2001

Title: APPARATUS AND METHOD FOR ATMOSPHERIC

PRESSURE REACTIVE ATOM PLASMA PROCESSING

FOR SHAPING OF DAMAGE FREE SURFACES

**PATENT APPLICATION** 

Art Unit:

1763

Examiner:

A.W. Olsen

Customer No. 23910

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8** 

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on \_

Tianxiong Xue, Reg. No. 54,554

Signature Date: \_\_

## RESPONSE E TO OFFICE ACTION UNDER 37 C.F.R. §1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Response E is made in reply to the Office Action mailed July 23, 2004. No fee is due.

## **Amendments**

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims which begins on Page 2 of this paper.

Remarks begin on Page 14 of this paper.